

φ100

基盤シリコン（膜付け面ポリッシュ）

0.5mm幅線（120nm）

 FiveLab

 FiveLab

400μ

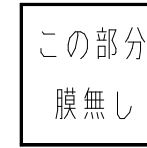
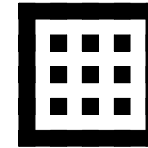
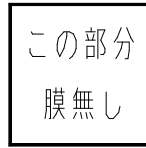
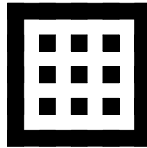
96nm

NONE

500μ

22nm

NONE



110nm

125nm

407nm

60nm

125nm

206nm



200μ

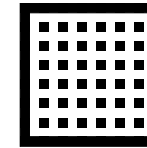
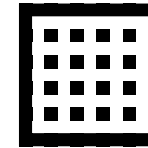
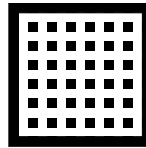
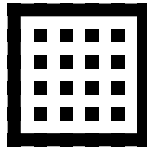
606nm

50μ

100μ

892nm

50μ



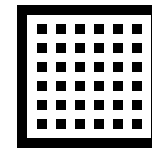
S/N _____

S/N _____

15角

500μ

50μ



この部分膜無し

文字線幅0.3mm

文字類膜厚120nm

黒部が膜

■ ■ 正方形の隙間は正方形の辺の幅と同一